



ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3555**
Takayuki ABE et al. : Attorney Docket No. 2005_1034A
Serial No. 10/540,487 : Group Art Unit 1794
Filed June 23, 2005 : Examiner Hoa T. Le

POLYGONAL BARREL SPUTTERING
DEVICE, POLYGONAL BARREL
SPUTTERING METHOD, COATED FINE
PARTICLE FORMED BY THE DEVICE AND
METHOD, MICRO CAPSULE, AND METHOD
OF PRODUCING THE MICRO CAPSULE

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
DEPOSIT
ACCOUNT NO. 23-0975

Mail Stop: **AMENDMENT**

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

Pursuant to the requirement contained in the Office Action mailed July 9, 2008,
applicants hereby elect Group I, claims 1-4 and 20-22, drawn to a polygonal barrel sputtering
device.

In view of this election, a full examination on the merits of the present application is
respectfully requested.

Respectfully submitted,

Takayuki ABE et al.

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